



OKI.206

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Masahiro Yoshida et al.

Group Art Unit: 2818

Serial No.: 09/759,639

Examiner: T. Ho

Filed: January 16, 2001

For: SEMICONDUCTOR DEVICE HAVING A THICK OXIDE LAYER UNDER GATE SIDE WALLS AND METHOD FOR MANUFACTURING THE SAME

RESPONSE TO QUAYLE ACTION

Honorable Assistant Commissioner for Patents
Washington, D.C. 20231

Date: September 13, 2002

Sir:

In response to the Quayle Office Action dated August 21, 2002, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

In the Claims:

Please cancel claims 16 and 17 without prejudice or disclaimer of the subject matter therein.

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